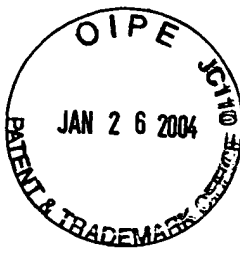


Image



2814

Attorney Docket No. 0756-2119

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Hisashi OHTANI et al.

Serial No. 09/550,598

Filed: April 17, 2000

For: SEMICONDUCTOR DEVICE AND
PROCESS FOR PRODUCING THE
SAME

) Group Art Unit: 2814

) Examiner: P. Cao

) CERTIFICATE OF MAILING

) I hereby certify that this correspondence is being
) deposited with the United States Postal Service
) with sufficient postage as First Class Mail in an
) envelope addressed to: Commissioner for Patents,
) P.O. Box 1450, Alexandria, VA 22313-1450, on
) January 23, 2004.

) Adelle M. Stanger

AMENDMENT

Honorable Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated October 23, 2003, please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 8 of this paper.